HIGH-POWER TESTS AND INITIAL ELECTRON BEAM MEASUREMENTS OF THE NEW HIGH-GRADIENT NORMAL CONDUCTING RF PHOTOINJECTOR SYSTEM FOR THE SINCROTRONE TRIESTE

L. Faillace[#], R. Agustsson, P. Frigola, A. Verma, Radiabeam Technologies LLC, CA, USA H. Badakov, A. Fukasawa, J. Rosenzweig, A. Yakub, Department of Physics and Astronomy, UCLA CA, USA

F. Cianciosi, P. Craievich, M. Trovo', Sincrotrone Trieste, Italy

Abstract

Radiabeam Technologies, in collaboration with UCLA, presents the development of a high gradient normal conducting radio frequency (NCRF) 1.6 cell photoinjector system, termed the Fermi Gun II, for the Sincrotrone Trieste (ST) facility. Designed to operate with a 120MV/m accelerating gradient, this single feed, fat lipped racetrack coupler design is modeled after the LCLS photoinjector with a novel demountable cathode which permits cost effective cathode exchange. Full overview of the project to date, installation, high-power RF conditioning and initial electron beam emittance measurements at Sincrotrone Trieste will be discussed along with basic design, engineering and manufacturing.

INTRODUCTION

Radiabeam is currently involved in the development of new technology aimed at high average power operation for a NCRF electron gun system, the FERMI II RF Gun, for the Sincrotrone Trieste facility operating at the frequency of 2.99801GHz with a repetition rate >50Hz.

The gun design was originally based on the UCLA-University of Roma-INFN-LNF [1] high repetition rate photoinjector for SPARX project, which borrowed the main features from the LCLS gun [2,3]. Nevertheless, the basic design was re-optimized by request of ST with two main changes: 1) an exchangeable cathode plate for easy exchange of different material samples; 2) single-feed for a cost-effective and more compact device.

RF GUN DESIGN

The RF design of the Gun has been performed by using the codes SuperFish [4] and HFSS [5]. Figure 1 shows half structure of the RF gun with surface electric field distribution calculated by HFSS. The RF power is fed through one waveguide only (top one); the symmetrical waveguide, acting as a dummy waveguide, forbids the propagation of the electromagnetic field that is below its cutoff value (i.e. the dummy waveguide has a width much smaller than the input one). The main purpose of the second waveguide is to cancel the field dipole component.

#faillace@radiabeam.com

694

Cell Design



Figure 1: 3D model used for HFSS simulation. Surface electric field is shown.

The RF cavity shape, as proposed, has several innovative electromagnetic features, including Z-coupling and enhanced cell-to-cell coupling to produce higher mode separation, elliptical irises to reduce surface electric field, symmetric couplers for dipole mode minimization, racetrack geometry to minimize quadrupole field components. In contrast to the LCLS gun, which has these features, it is externally fed only by one side, avoiding the need of a power splitter and making the whole assembly much more compact, easier to handle and cost efficient.

In order to calculate the maximum surface electric field, we normalize the on-axis field to 120 MV/m at the cathode. The peak field on the iris is found to be 102 MV/m, below the breakdown safety threshold.

Per usual procedure, a first pass on the RF design was made with SUPERFISH and then HFSS was used to provide a complete picture of the RF performance, including mode frequencies, field balance, quality factor *Q*, shunt impedance and external coupling.

The design parameters achieved in simulation through this process are summarized below in Table 1.

Parameter	Simulated value
π -mode frequency	2.998 GHz
$0-\pi$ mode separation	14.2 MHz
Quality factor Q ₀	13,750
External coupling β	1.8
Shunt Impedance R _{Shunt}	60.8 MΩ/m
Peak Surface E	102 MV/m
(120 MV/m @cathode)	
nput power P	<10 MW

Table 1: Main RF Parameters

Dipole and Quadrupole Component

The dipole and quadrupole components of the RF field have been evaluated using HFSS. The symmetry of the Zcoupling structure guarantees cancellation of the RF dipole component, apart from a negligible (in high-Q standing wave devices) transient from the single-side RF feed. The quadrupole field, on the other hand, is managed by adjusting the "race-track" spacing.

GUN FABRICATION, TUNING AND LOW-POWER MEASUREMENTS

The RF Gun was machined in-house and all the brazing cycles at SLAC, followed by final tuning. The Gun after the final brazing step is shown in Figure 2.



Figure 2: Picture of the Fermi II Gun after final brazing.

In order to check the simulated parameters, we performed low-power measurements by using a Vector Network Analyzer (VNA). The comparison is given in Table 2, showing good agreement.

Table 2: Comparison between Simulations and Measurements of the Main RF Parameters

	Measurement	HFSS
Frequency	2.99801 GHz	2.998GHz
	(19 C, 40% humidity)	
Mode	14.5 MHz	14.2 MHz
Separation		
Q ₀	13,350	13,750
Coupling	1.85	1.8
beta		

The reflection coefficient at the input RF waveguide is shown in Fig. 3. The tuning frequency was set to 2.99801, at 19° C and 40% humidity (assuming an operating temperature of 38° C).



Figure 3: Reflection coefficient. Data (red dots) and fit (blue line).

The balance of the electric field profile was measured by means of the bead-drop procedure and using a 2mm dielectric spherical bead. The good agreement between data and fit is given in Fig. 4.



Figure 4: On-axis electric field profile. Data (red dots) and fit (blue line).

INSTALLATION AND HIGH-POWER RF CONDITIONING



Figure 5: Installation of the Fermi II Gun inside the tunnel at Sincrotrone Trieste.

The Fermi II Gun Installation started in Trieste on January 4th 2013 (Figure 5). The gun was brought under vacuum in a test area to check if any leaks were present as well as the frequency shift that resulted to be about 800 kHz, as expected.

A dedicated area for high-power gun testing is located behind the current RF gun station. The Fermi II gun was installed in this area to start high-power conditioning. The input power was raised up to 11MW and a repetition rate of 50Hz. The conditioning between 10Hz and 50Hz, given in the chart in Fig. 6, required a temperature variation of only -2°C. The vacuum base level was 2.4E-9 mbars.



Figure 6: Monitoring of the high-power conditioning and vacuum levels.

The first electron beams were generated by using the laser profile shown in Figure 7.



Figure 7: Left, laser spot transverse profile; right, pulse length profile.

The output energy was 5.1 MeV for 8MW of input RF power. Although the laser spot was not optimized yet, the quantum efficiency showed a good value of about QE=3.3E-5, see Figure 8.



Figure 8: Charge yield as function of laser energy.

The first emittance measurement was performed with a 500 pC beam at 100 MeV, by using the quadrupole scan technique. In Figure 9, we show the result for the measured transverse normalized emittance on the vertical plane with a promising value of 0.67 microns.



Figure 9: Initial emittance measurement of a 500pC beam.

CONCLUSIONS

We have presented the RF design, fabrication, highpower RF conditioning and initial beam measurements of the new Fermi II RF Gun. Innovative features to the class of RF Guns, such as elliptical irises and an exchangeable cathode system, improve the performance of this gun in terms of power handling and robustness. The removable cathode assembly showed good thermal performance even at 50Hz. The initial measurements of the beam normalized emittance are very promising.

ACKNOWLEDGMENT

I would like to thank Mauro Trovo' (ST) for providing material on the initial beam measurements.

REFERENCES

- [1] L. Faillace *et al.*, " An Ultra-high repetition rate Sband RF Gun", FEL Conference 2008
- [2] C.Limborg *et al.*, "RF Design of the LCLS Gun", LCLS Technical Note LCLS-TN-05-3 (Stanford, 2005).
- [3] D.H. Dowell *et al.*, "The development of the Linac Coherent Light Source RF Gun", SLAC Menlo Park CA, published in the ICFA Beam Dynamics Newsletter No. 46.
- [4] http://laacg1.lanl.gov/laacg/
- [5] http://www.ansoft.com/products/hf/hfss

06 Accelerator Systems T02 - Electron Sources and Injectors

ISBN 978-3-95450-138-0